

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DAVID J. BAIN, ET AL. )  
Serial No.: 10/710,653 ) Group Art Unit: 2836  
Filed: July 27, 2004 )  
For: PRESSURE ASSISTED WAFER )  
HOLDING APPARATUS AND )  
CONTROL METHOD ) Examiner: Roman, L.  
 ) Confirmation No.: 4652

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed October 10, 2006, please amend the Application as follows: